



AF/2800

10/Q (N.E.)
G. Stanley
6-13-03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Haruo Hyodo et al.

Art Unit : 2818

Serial No. : 09/963,839

Examiner : Quoc Dinh Hoang

Filed : September 26, 2001

Title : SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF

MAIL STOP AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

REPLY

In reply to the action mailed March 5, 2003, please amend the application as indicated on the following pages. Applicant asks that all claims be allowed in view of the amendment to the claims and remarks contained on the following sheets, a total of 5 pages.

Please apply any other charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: June 5, 2003

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CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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